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CONFIRMATION NO. 6595

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APPLICANTS								
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CONTINUING DATA								
** FOREIGN APPLICATIONS ************************************								
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/02/2003								
NDEPENDENT								
CLAIMS 3								
92618 TITLE Method for mitigating chemical vapor deposition phosphorus doping oxide surface induced defects								
All Fees 1.16 Fees (Filing)								
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